

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination YAMAZAKI ET AL.	
		Examiner Monica Lewis	Art Unit 2822	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,835,607	12-2004	Takemura et al.	438/163
	B	US-6,093,934	07-2000	Yamazaki et al.	257/51
	C	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	S. Wolf, Silicon Processing for the VLSI Era, Lattice Press, Volume 2, Page 398 and 399.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.